

In re Application of:

Takaharu KONDO, et al.

Application No.: 09/982,845

Filed: October 22, 2001

For: SILICON-BASED FILM AND PHOTOVOLTAIC

ELEMENT

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Docket No.: 03500.015894. (35.C15894)

Examiner: S. A. Gebremariam

Group Art Unit: 2811

Date: October 29, 2003

Sir:

Transmitted herewith is a Request for Reconsideration in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

		CLA	AIMS AS AMEND	ED	,	
	CLAIMS REMAINING AFTER AMENDMENT	•	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	8	MINUS	20	= 0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	1	MINUS	3	= 0	x \$43 \$86	\$ 0.00
Fee for Multiple Dependent claims \$145°/\$290 TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0.00

°Verified Statement claiming sr	nall entity status	is enclos	sed, if not	filed previously.
A check in the amount of \$	is enclosed.		•	

	Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.
X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.
X	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants Damond E. Vadnais Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Examiner: S. A. Gebremariam			
Takaharu KONDO, et al.)			
Application No.: 09/982,845	: Group Art Unit: 2811)			
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For: SILICON-BASED FILM AND PHOTOVOLTAIC ELEMENT) : October 29, 2003			
Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 REOUEST FOR REO	RECEIVED TECHNOLOGY CENTER TO SIDERATION			

Sir:

In response to the Office Action dated July 30, 2003, reconsideration and allowance of the subject application are respectfully requested.